

Notice of References Cited

 Application/Control No.
 10/656,879

 Applicant(s)/Patent Under
 Reexamination
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 Examiner
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 2872
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U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-3,933,504	01-1976	Phillips et al.	430/2
	B	US-6,373,806	04-2002	Kitamura et al.	369/103
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
*	U	L.Galambos et al., "Doubly doped stoichiometric and congruent lithium niobate for holographic data storage", Journal Crystal Growth, 229, pp. 228-232(2001)
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
 Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.